IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: John E. Peterson, et al.

Attorney Docket No.: IL-10786

Serial No. :

Art Unit:

Filed

Examiner:

For

: Reduction of Damage Initiation Density in Fused Silica Optics

via UV Laser Conditioning

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Forwarded herewith is an Information Disclosure Statement, Form-1449, in the above-identified application. Copies of the cited references are enclosed: 11 U.S. Patents and 1 Other Disclosure.

The above-mentioned disclosures, which are not admitted as prior art, are identified on the enclosed Form 1449.

Respectfully submitted,

Dated: July 25,2001

Eddie E. Scott

Attorney for Applicant Registration No. 25,220

Enclosures: As noted above